

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L22	3477	(356/399-401,124).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/01/17 19:03
L23	2904	(356/237.1,237.2,237.5,239.1,239.3).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/01/17 19:04
L24	1587	(356/625-630,634,635).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/01/17 19:04
L25	8059	(430/5,22,30).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/01/17 19:04
L26	7283	(355/53,55,77).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/01/17 19:05
L27	2496	(250/548,559.19-559.22,559.24,559.27,559.28).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/01/17 19:05
L28	3674	(438/5,7,14,16).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/01/17 19:05
L29	486	(22 23 24 25 26 27 28) and ((grid mesh) same (reflect\$3 reflectance))	US-PGPUB; USPAT; USOCR	OR	ON	2007/01/17 19:37
L30	337	29 and ((grid mesh) same (dimension profil\$3 line width length linewidth thickness))	US-PGPUB; USPAT; USOCR	OR	ON	2007/01/17 19:37
L31	146	30 and ((grid mesh) same (wafer substrate semiconduct\$3))	US-PGPUB; USPAT; USOCR	OR	ON	2007/01/17 19:38
L32	4259	((grid mesh) same (reflect\$3 reflectance))	FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/01/17 19:37
L33	932	32 and ((grid mesh) same (dimension profil\$3 line width length linewidth thickness))	FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/01/17 19:37
L34	152	33 and ((grid mesh) same (wafer substrate semiconduct\$3))	FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/01/17 19:38